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CONFIRMATION NO. 8085

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RULE				
APPLICANTS Mitsugu Abe, Atsugi-shi, JAPAN; Nobuyoshi Nambu, Yokkaichi-shi, JAPAN; Osamu Ito, Yokkaichi-shi, JAPAN; Masaaki Ogitsu, Tsukuba-shi, JAPAN; Kazuo Inomata, Tokyo, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP04/03642 03/18/2004				
** FOREIGN APPLICATIONS ***** JAPAN 2003-074581 03/18/2003				
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/04/2006				
Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	Initials	JAPAN	6
Verified and Acknowledged	/ROBERT A ROSE/ Examiner's Signature			TOTAL CLAIMS
				14
				INDEPENDENT CLAIMS
				2
ADDRESS OBLON, SPIVAK, MCCLELLAND MAIER & NEUSTADT, L.L.P. 1940 DUKE STREET ALEXANDRIA, VA 22314 UNITED STATES				
TITLE Material for purification of semiconductor polishing slurry, module for purification of semiconductor polishing slurry and process for producing semiconductor polishing slurry				
FILING FEE RECEIVED 1460	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees		
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